## IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicants: MATTHEE, Thorsten et al.

Serial No: 10/086,190

Filed February 28, 2002

For: APPARATUS AND METHOD FOR COATING A SUBSTRATE

BY MEANS OF A CHEMICAL GAS PHASE SEPARATION PROCESS

Examiner: Colaranni, M.

Art Unit. 1731

## CERTIFICATE OF FACSIMILE TRANSMISSION

The undersigned hereby certifies that this document was forwarded via facsimile to Examiner M. Colainnu, facsimile humber (703) 872-9494, U.S. Patent and Trademark Office on the 174\*\*—day of June, 2003.

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PRELIMINARY AMENDMENT

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06-17/03

Prior to the examination of the above-referenced application, as extended, Applicants 60 00°91 respectfully request entrance of the attached Amendment.

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## AMENDMENT

Please amend the above-identified application as follows:

## In the claims:

Please cancel claims 5 and 12-15, without prejudice or disclaimer.

Please rewrite the following claims:

 (Amended Ouce) An apparatus for coating a substrate having a complex outer surface by means of a chemical gas phase separation process, the apparatus comprising:

an arrangement of filaments constructed and arranged to at least partially surround and conform to the outer surface of the complex substrate, wherein the distance between the filaments and the outer surface of the substrate remains substantially the same.